

ABSTRACT OF THE DISCLOSURE

A substrate is placed on a Y-axis movement table, and a syringe containing paste is rendered capable of applying paste while moving in an X-axis direction on a head mechanism. Since the head mechanism provided with the syringe is rendered movable in the Y-axis direction by the Y-axis movement mechanism, a distance of movement of the syringe containing paste in the Y-axis direction is reduced, and a mechanical load on the head mechanism is reduced as well. Accordingly, production of metal dust attributable to abrasions and the like are suppressed, and it is possible to achieve high-quality and efficient paste pattern formation.